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Contents

- *Symposium Committees*
- *Conference Committee*

PLASMONICS II

- 12774 06 **Analysis of sensing characteristics of plasmonic elliptical ring resonator based refractive index sensor (Invited Paper)** [12774-6]

PLASMONICS III

- 12774 0C **Application of SERS method for detection of methotrexate molecules in human plasma** [12774-13]
- 12774 0D **Self-assembled plasmonic silver nanoparticle films on anodic alumina for SERS applications** [12774-14]

PLASMONICS IV

- 12774 0J **Plasmonic nanostructures for environmental monitoring and/or biological applications** [12774-20]

PLASMONICS V

- 12774 0O **Strong coupling of the guided modes with BIC generation in graphene-based one-dimensional dielectric gratings** [12774-25]

POSTER SESSION

- 12774 0Q **Dual-parameter sensor for refractive index and temperature sensing based on surface plasmon resonance** [12774-10]
- 12774 0S **Ultra-wideband polarization conversion metasurface at microwave frequencies** [12774-28]
- 12774 0U **Near-field enhanced optoelectronic performance of Si thin film** [12774-30]